



Docket No. 43521-1200

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tetsushi Yamaguchi et al.

Serial No.: 10/718,068

Filed: 11/20/2003

For: PARTICLE SIZE DISTRIBUTION
ANALYZER

Patent Examiner:

Group Art Unit: 2877

May 3, 2006

Costa Mesa, California 92626

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references, which were found during the prosecution of a co-pending

Japanese Patent Application:

Japanese Patent Application Publication No. 2002-005813
Japanese Patent Application Publication No. 02-212741
Japanese Patent Application Publication No. 06-221989
Japanese Patent Application Publication No. 6-12942
Japanese Patent Application Publication No. 08-178825
Japanese Patent Application Publication No. 62-058138

Copies of these foreign references and a form PTO-A820 are attached.

The undersigned attorney hereby certifies that each item contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart international application not more than three months prior to filing this statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patent, PO Box 1450, Alexandria, VA 22313-1450, on May 3, 2006

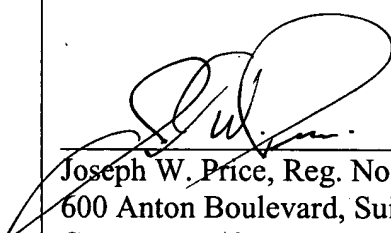
by: Sharon Farnus

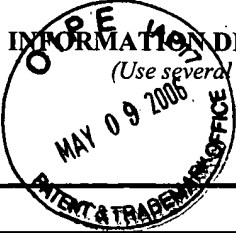

Signature

Date of Signature: May 3, 2006

Very truly yours,

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				Docket Number (Optional)		Application Number		
				43521-1200		10/718,068		
				Applicant(s)				
				Tetsushi Yamaguchi et al.				
				Filing Date		Group Art Unit		
				November 20, 2003		2877		
U. S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U.S. PATENT APPLICATION PUBLICATIONS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2002-005813	1.9.2002	Japan			X	
		02-212741	8.23.1990	Japan w/English Abstract			X	
		06-221989	8.12.1994	Japan			X	
		6-12942	2.18.1994	Japan (w/ partial translation)			X	
		08-178825	7.12.1996	Japan			X	
		62-058138	3.13.1987	Japan w/English Abstract			X	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								